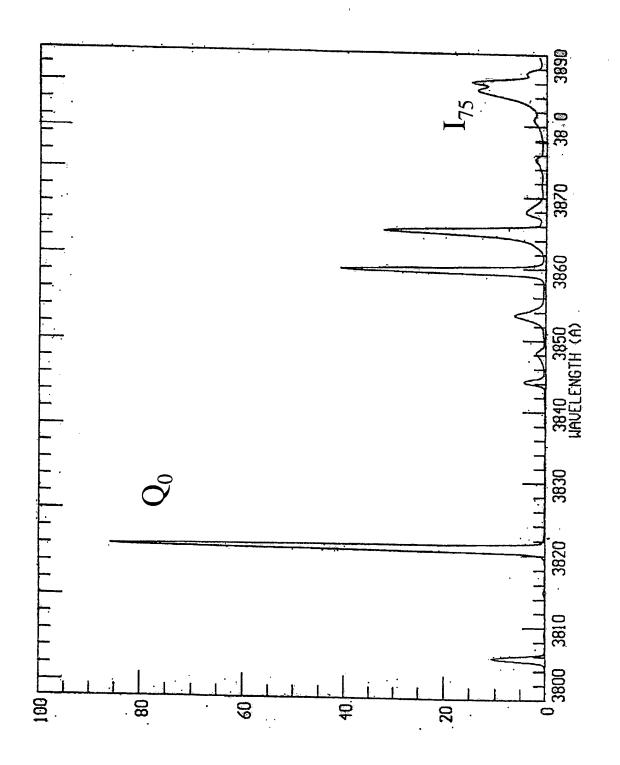
Reducing Nitrogen Content in Silicon Carbide Crystals by Sublimation Growth in a Hydrogen-Containing Ambient In re: George Fechko Attorn y Docket No. 5000.302



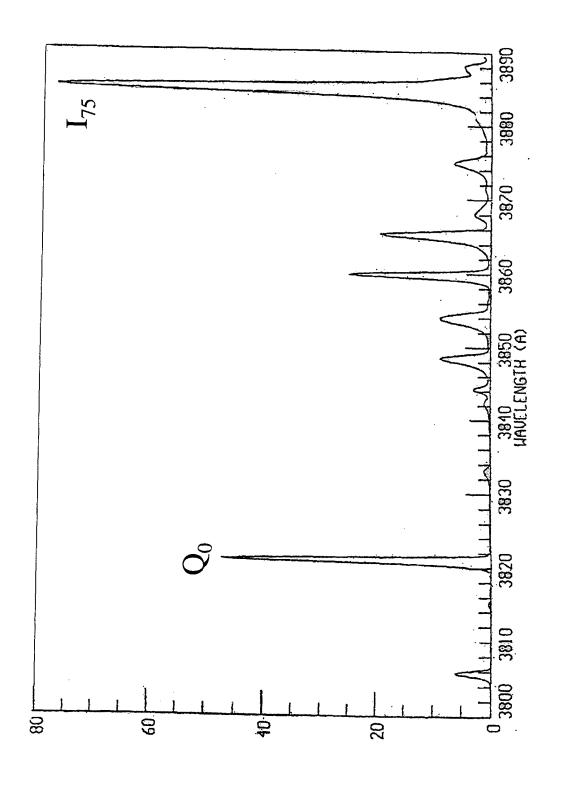


Figure 2